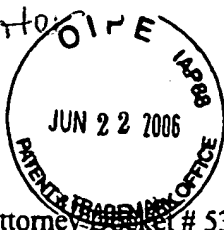


Do not enter
NY 6/29/06



Attorney # 5367-69

AP/2FW

MS-AF
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Volker HARLE et al.

Serial No.: 10/780,317

Filed: February 17, 2004

For: Method for Fabricating a Plurality of
Semiconductor Bodies, and Electronic
Semiconductor Body

Examiner: Novacek, Christy L.
Group Art: 2822

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

June 19, 2006
(Date of Deposit)

Thomas Langer
Name of applicant, assignee or Registered Representative

Thomas Langer
Signature

June 19, 2006
Date of Signature

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

SIR:

In response to the final Office Action dated March 17, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.